



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818  
Examiner: David Nhu

Re PATENT APPLICATION of:

Applicant(s) : Takashi NAKAMURA

Serial No. : 09/856,818

Filed : May 25, 2001

For: METHOD OF FORMING SOLID OF A FERROELECTRIC  
OR HIGH DIELECTRIC MATERIAL AND METHOD OF  
MANUFACTURING SEMICONDUCTOR DEVICE  
EMPLOYING THE SAME

Attorney Ref. : AI 265NP

INFORMATION DISCLOSURE  
STATEMENT

Notice of Allowance Date: November 7, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(d) after Notice of Allowance, but before payment of the Issue Fee. As required by 37 C.F.R. §1.97(e)(1), it is certified that each item submitted with this Information Disclosure Statement was first cited in the attached Office Action from the Japanese Patent Office in a counterpart foreign application on October 7, 2003, that is, less than three months prior to filing this Information Disclosure Statement.

Enclosed are copies of the Japanese Patent publication and the PCT application cited therein. The relevance of the Japanese publication can be gleaned from the attached English language Abstract. The documents are listed on the attached Form PTO-1449. Also enclosed is the applicable fee of \$180.00 required by 37 C.F.R. §1.17(p).

Consideration of the submitted documents is respectfully requested.

Respectfully submitted,

  
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November 21, 2003

Date

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<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>				Atty. Docket  AI 265NP		Application No.  09/856,818	
				Applicant Takashi NAKAMURA et al			
				Filing Date May 25, 2001		Group 2818	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	WO 96/29726	9/26/96	PCT			English
	AJ	05-85706	6/4/93	JAPAN			Entire
	AK						
	AL						
	AM						
	AN						
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							